

	Hits	Search Text
1	1	("6005988").PN.
2	17	(resizing near3 (pattern or image)) same pixel same spatial\$3
3	1147453	(lithography or photolithography or expos\$5)
4	4	S2 and S3
5	83	((resiz\$3 or render\$3 or reimag\$3 or imag\$3 or display\$3) near3 (pattern or image)) same pixel same (spatial\$3 near2 offset)
6	32	S5 and S3
7	32	S6 not S4
8	11583	slm or dmd or (micromirror adj array) or ((micro adj mirror) adj array)
9	1515373	(substrate or wafer)or S3
10	7900	S8 and S9
11	2383	((resiz\$3 or render\$3 or reimag\$3 or imag\$3 or display\$3 or generat\$3) near3 (pattern or image)) same S8
12	4	((resiz\$3 or render\$3 or reimag\$3 or imag\$3 or display\$3 or generat\$3) near3 (pattern or image)) same S8 same pixel same (spatial\$3 near offset)
13	6	((resiz\$3 or render\$3 or reimag\$3 or imag\$3 or display\$3 or generat\$3) near3 (pattern or image)) same S8 same (spatial\$3 near offset)
14	0	S13 and S10

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5/31/05.